Application Data Sheet

Secrecy Order in Parent Appl.?::

Application Information

Regular Application Type:: Utility Subject Matter:: Suggested Classification:: Suggested Group Art Unit:: CD-ROM or CD_R?:: None Number of CD disks:: Number of copies of CDs:: No Sequence Submission:: Computer Readable Form (CRF)?:: No Title:: METHOD OF MANUFACTURING FERROELECTRIC SUBSTANCE THIN FILM AND FERROELECTRIC MEMORY USING THE FERROELECTRIC SUBSTANCE THIN FILM 12844.15USD1 Attorney Docket Number:: Request For Early Publication:: No Request For Non-Publication:: No Suggested Drawing Figure:: Total Drawing Sheets:: 5 Small Entity:: No Latin Name:: Variety Denomination Name:: Petition Included:: No Petition Type:: Licensed US Govt. Agency:: Contract or Grant Numbers::

No

Applicant Information

Applicant Authority Type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Yoshikazu

Middle Name::

Family Name::

Fujimori

Name Suffix::

City of Residence::

Kyoto-shi

State or Province of Residence::

Country of Residence::

Japan

Street of mailing address::

c/o Rohm Co., Ltd., 21, Saiin Mizosaki-cho, Ukyo-

ku

City of mailing address::

Kyoto-shi

State or Province of mailing address::

Kyoto

Country of mailing address::

Japan

Postal or Zip Code of mailing address:: 615-0045

Correspondence Information

Correspondence Customer Number::

23552

Representative Information

23552

Domestic Priority Information

Application::	Continuation Type::	Parent Application::	Parent Filing Date::
This application	Division of	10/218988	08/13/02

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2001-264070	08/14/01	Yes

Assignee Information

Assignee Name::

Rohm Co., Ltd.

Street of mailing address::

21, Saiin Mizosaki-cho, Ukyo-ku

City of mailing address::

Kyoto-shi

State or Province of mailing address::

Kyoto

Country of mailing address::

Japan

Postal or Zip Code of mailing address:: 615-0045